

Application Data Sheet Information

Application Type:	Regular
Subject Matter:	Utility
Title:	Dry Etching Process For Compound Semiconductors
Attorney Docket Number:	P1572
Request for Early Publication:	No
Request for Non-Publication:	No
Suggested Drawing Figure:	2C
Total Drawing Sheets:	5
Small Entity:	No

Inventor Information

Inventor Authority type:	First Inventor
Primary Citizenship Country:	P. R. China
Status:	Full Capacity
Given Name:	Jennifer
Middle Name/Initial:	
Family Name:	Wang
City of Residence:	Redondo Beach
Country of Residence:	USA
Street address:	1800 S. Pacific Coast Hwy. Unit #44
City:	Redondo Beach
State or Province:	California
Postal or Zip Code:	90277

Inventor Authority type:	Second Inventor
Primary Citizenship Country:	USA
Status:	Full Capacity
Given Name:	Huai-Min
Middle Name/Initial:	
Family Name:	Sheng
City of Residence:	Cerritos
Country of Residence:	USA
Street address:	13141 Semora Place
City:	Cerritos
State or Province:	California
Postal or Zip Code:	90703

Inventor Authority type:	Third Inventor
Primary Citizenship Country:	USA
Status:	Full Capacity
Given Name:	Mike
Middle Name/Initial:	
Family Name:	Barsky
City of Residence:	Sherman Oaks
Country of Residence:	USA
Street address:	13424 Cumpston Street
City:	Sherman Oaks
State or Province:	California
Postal or Zip Code:	91401

Correspondence Information

Firm Name:	LaRiviere, Grubman & Payne, LLP
Street address:	P.O. Box 3140
City:	Monterey
State or Province:	California
Postal or Zip Code:	93942
Telephone:	(831) 649-8800
Fax:	(831) 649-8835

Representative Information

Designation:	Registration number:	Name:
Primary	Customer Number: 24,394	LaRiviere, Grubman & Payne, LLP

Assignee Information

Assignee Name:	Northrop Grumman Space & Mission Systems Corporation
Street Address:	One Space Park, Bldg. R11/2796BE, Space Technology, M/S 1492
City:	Redondo Beach
State or Province:	California
Country:	USA
Postal or Zip Code:	90278